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UNITED STATES PATENT AND TRADEMARK OFFICE  
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MAR 18 2004

In re Application of  
Jeng H. Hwang  
Serial No. 09/896,786  
Filed: June 29, 2001  
For: METHOD FOR ALLOWING A STABLE  
POWER TRANSMISSION INTO A PLASMA  
PROCESSING CHAMBER

RECEIVED

MAR 22 2004

TC 1700

NOTICE OF WITHDRAWAL  
FROM ISSUE  
UNDER 37 CFR 1.313(b)

The above-identified application is withdrawn from issue after payment of the issue fee due to reopening of prosecution. See 37 CFR 1.313 (b).

The above-identified application is hereby withdrawn from issue.

The issue fee is refundable upon written request. If, however, the application is again found allowable, the issue fee can be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Issue Fee Due upon written request. This request and any balance due must be received on or before the due date noted in the new Notice of Allowance in order to prevent abandonment of the application.

Telephone inquiries should be directed to at Gregory Mills (703) 308-1633.

The above-identified application is being forwarded to the examiner for prompt appropriate action, including notifying applicant of the new status of this application.

*J. Stone*

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cc: Allowed Files—Pk3-910